

## Electrical Characterization of Electrodeposited *p*-type Semiconducting Cu<sub>2</sub>O Films

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Cu<sub>2</sub>O films with a cuprite cubic structure have been prepared by cathodic electrodeposition at 318 K from an aqueous solution containing a lactic acid and copper sulfate hydrate. The electrical characterizations were carried out on the free-standing films prepared by splitting from the substrate at room temperature with a van der Pauw technique using a hall measuring system. The Cu<sub>2</sub>O film showed *p*-type conduction irrespective of solution pH value. The resistivity, carrier concentration, and mobility strongly related to the solution pH value. And the Cu<sub>2</sub>O film prepared at pH 12.5 showed resistivity of  $2.7 \times 10^4 \Omega\text{cm}$  with carrier concentration of  $1.9 \times 10^{14} \text{cm}^{-3}$  and mobility of  $1.2 \text{cm}^2\text{V}^{-1}\text{s}^{-1}$ .

Key words: cuprous oxide, cuprite structure, electrodeposition, *p*-type conduction, electrical property

### 1. INTRODUCTION

Cu<sub>2</sub>O is a *p*-type semiconductor with band gap energy of 2.1 eV and has attracted increasing attention as a component in devices such as solar cell and photo diode. The Cu<sub>2</sub>O films have been prepared by gas-phase deposition techniques such as radio-frequency magnetron sputtering, molecular beam epitaxy, and laser ablation techniques.

Electrodeposition of oxide films from aqueous solutions has several advantages over gas-phase deposition processes, is less hazardous and environmentally friendly, and is low temperature process. Semiconductors of ZnO,<sup>1,2</sup> CeO<sub>2</sub>,<sup>3</sup> and a-Bi<sub>2</sub>O<sub>3</sub>,<sup>4</sup> and ferromagnetic material of Fe<sub>3</sub>O<sub>4</sub><sup>5</sup> were prepared directly by electrodeposition and chemical deposition from aqueous solutions. Also, electrodeposition of Cu<sub>2</sub>O film from an aqueous solution has been demonstrated by Switzer's group, and the Cu<sub>2</sub>O film showed optical band gap energy of 2.1 eV.<sup>6</sup> The evaluation of electrical characteristics for electrodeposited Cu<sub>2</sub>O films is difficult, because of the existence of conductive substrate. However, the electrical characteristic is so important for the applications of electrical devices. Recently, it was reported that electrodeposited CdTe films could be evaluated on the free-standing films prepared by splitting from the conductive substrate with an epoxy-type adhesive.<sup>7</sup>

In this paper, we prepared *p*-type semiconducting Cu<sub>2</sub>O films by cathodic deposition from an aqueous solution Switzer's group reported, and the electrical characterizations were carried out by using a hall-measuring system.

### 2. EXPERIMENTAL

Cu<sub>2</sub>O films were prepared by cathodic deposition at 318 K on a conductive glass substrate (NESA glass, 20

Ω) from an aqueous solution containing a 0.4 mol/L copper sulfate hydrate and 3 mol/L lactic acid. The solution was prepared by reagent grade chemicals and distilled water. The solution pH was adjusted at 9.5 and 12.5 with an 1 mol/L NaOH aqueous solution. The electrodeposition was carried out potentiostatically at a cathodic potential of -0.55 V referenced to Ag/AgCl electrode by using a potentiostat connecting to a coulomb meter.

X-ray diffraction measurements were performed by a conventional  $\theta/2\theta$  scanning technique using a MAC Science MXP18 system with a monochromated Cu K $\alpha$  radiation source. Electron spectra were recorded with an ESCA (ULVAC-PHI5700MC) with a monochromated Al K $\alpha$  radiation source. Electrical characterization was carried out on samples at ambient temperature using a hall-measuring system (Toyo Technika, Resitest 8320). The samples were prepared by splitting from the substrate by using a technique reported by Miyake.<sup>7</sup> Optical absorption spectrum was recorded with a spectrophotometer (Shimadzu, UV-3150).

### 3. RESULTS AND DISCUSSION

Cu<sub>2</sub>O film with a cuprite structure was obtained irrespective of pH value. And the lattice constant calculated from the X-ray diffraction peaks was 0.4270 nm, which agreed with the standard value. The Cu<sub>2</sub>O films had excellent preferred orientations of (111) and (200) depending on the pH value, as already reported by Switzer's group. It was confirmed from the electron spectra recorded with an XPS that the film was Cu<sub>2</sub>O and did not contain Cu and CuO. The molar ratio of Cu to O (Cu/O), which was evaluated from the intensity of Cu2p and O1s spectra and relative sensitivity factors, was estimated to be 1.8 and 1.6 for pH values of 9.5 and 12.5, indicating that the ratio changed depending on the

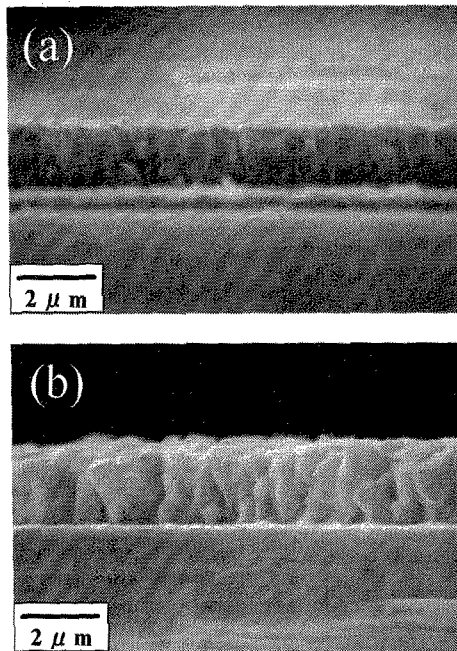


Figure 1 Scanning electron micrographs of cross-sectioned structure for  $\text{Cu}_2\text{O}$  films prepared at pH value of 9.5 and 12.5.

pH value, even if experimental and calculating errors were involved. Figure 1 shows cross-sectioned structure of  $\text{Cu}_2\text{O}$  films prepared at pH values of 9.5 and 12.5. The  $\text{Cu}_2\text{O}$  films were composed of columnar grains grown from the substrate surface. The grain sizes evaluated from the SEM micrographs were of around 0.25 and 0.6  $\mu\text{m}$  for the pH value of 9.5 and 12.5. Any defects such as pores could not locate on the images.

The  $\text{Cu}_2\text{O}$  film formation proceeds by a tri-dimensional growth mechanism, because of the columnar structure. The preferred orientation of resultant  $\text{Cu}_2\text{O}$  films is determined by the nucleation stages, which closely related to the interfacial energy. The change in preferred orientation with pH value is evidence of the importance of the interfacial energy, and indicates that the interfacial energy changes depending on the solution pH value.

Figure 2 shows electrical properties for  $\text{Cu}_2\text{O}$  films prepared at pH values of 9.5, 10.5 and 12.5. The  $\text{Cu}_2\text{O}$  films showed *p*-type conduction irrespective of pH value. The resistivity was  $6.9 \times 10^5 \Omega\text{cm}$  at pH 9.5 and decreased to  $2.7 \times 10^4 \Omega\text{cm}$  with the raise in pH value to 12.5. The carrier concentration and mobility were  $9.5 \times 10^{12} \text{cm}^{-3}$  and  $0.95 \text{cm}^2\text{V}^{-1}\text{s}^{-1}$  at pH 9.5 and increased to  $1.9 \times 10^{14} \text{cm}^{-3}$  and  $1.2 \text{cm}^2\text{V}^{-1}\text{s}^{-1}$  with the raise in pH value to 12.5. The resistivity, carrier concentration, and mobility corresponded to those prepared at ambient temperature by a magnetron sputtering technique. The decrease in resistivity with pH value was caused by the increase in carrier concentration and mobility. Figure 3 shows the relation between molar ratio of Cu to O and the carrier concentration for the  $\text{Cu}_2\text{O}$  films deposited under various conditions. The carrier concentration increased with the decrease in Cu/O molar ratio. It is generally accepted that *p*-type conduction for undoped  $\text{Cu}_2\text{O}$  film is originated from a copper vacancy.<sup>8</sup> This

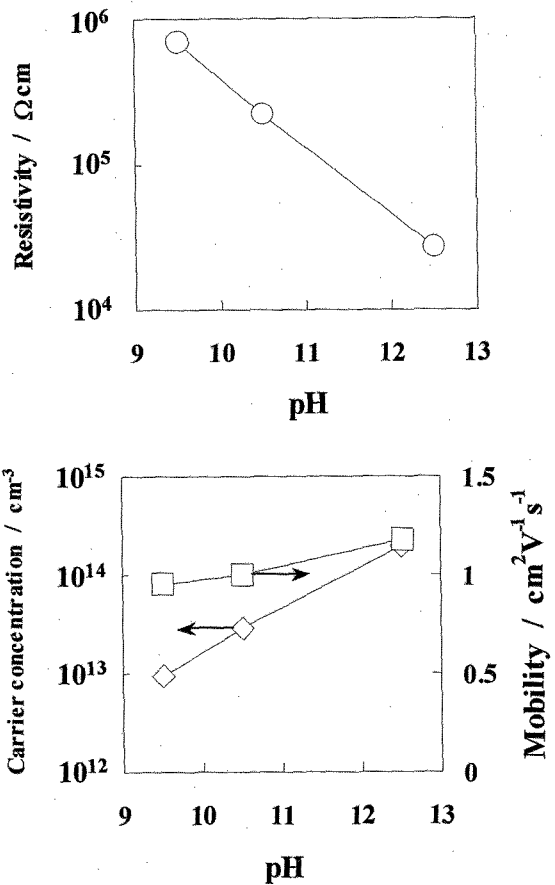


Figure 2 Electrical characteristics for  $\text{Cu}_2\text{O}$  films prepared at pH values of 9.5, 10.5, and 12.5.

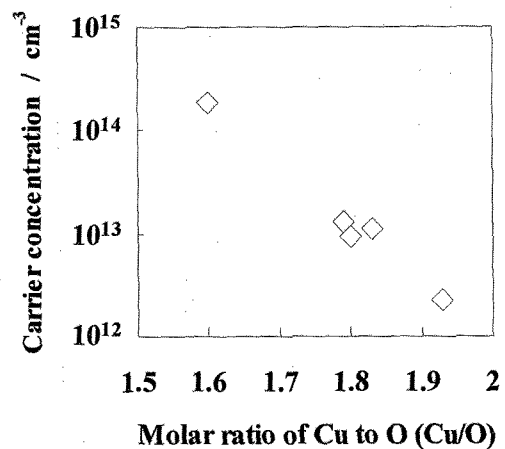


Figure 3 The relation between molar ratio of Cu to O (Cu/O) and carrier concentration.

will be the reason for the change.

The mobility in polycrystalline film should be generally limited by scattering from grain boundary, pore, and ionized impurity. Since the mobility is independent on the change in carrier concentration, the effectiveness of scattering from the ionized impurity including copper vacancies could not be seen. Because that the grain size increased with the raise in pH value,

the increase in mobility was attributed to the change in grain size.

The optical band gap energy was calculated from the absorption edge evaluated on the absorption spectrum with an assumption of direct transition and was estimated to be 2.1 eV characteristic of Cu<sub>2</sub>O.

#### 4. CONCLUSION

Cu<sub>2</sub>O films with a cuprite cubic structure have been prepared by cathodic electrodeposition at 318 K from an aqueous solution containing lactic acid and copper sulfate hydrate. The Cu<sub>2</sub>O film showed *p*-type conduction irrespective of solution pH value. The resistivity, carrier concentration, and mobility strongly related to the solution pH value. And the Cu<sub>2</sub>O film prepared at pH 12.5 showed resistivity of  $2.7 \times 10^4 \Omega \text{cm}$  with carrier concentration of  $1.9 \times 10^{14} \text{cm}^{-3}$  and mobility of  $1.2 \text{cm}^2 \text{V}^{-1} \text{s}^{-1}$ .

#### REFERENCES

1. M. Izaki, T. Omi, *Appl. Phys. Lett.*, **68**, 2439 (1996).
2. M. Izaki, J. Katayama, *J. Electrochem. Soc.*, **147**, 210 (2000).
3. M. Izaki, T. Saito, M. Chigane, M. Ishikawa, J. Katayama, M. Inoue, and M. Yamashita, *J. Mater. Chem.*, **11**, 1972 (2001).
4. J. A. Switzer, M. G. Shumsky, E. W. Bohannon, *Science*, **284**, 293 (1999).
5. M. Izaki, O. Shinoure, *Adv. Mater.*, **14**, 13, 142 (2001).
6. E. W. Bohannon, M. G. Shumsky, J. A. Switzer, *Chem. Mater.*, **11**, 2289 (1999).
7. M. Miyake, K. Murase, T. Hirato, Y. Awakura, *J. Electrochem. Soc.*, **150**, C413 (2003).
8. S. Ishizuka, T. Maruyama, K. Akimoto, *Jpn. J. Appl. Phys.*, **39**, L786 (2000).